

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Page 1 of 1 PTO Form 1449	Attorney Docket No. 46884-5518	Serial No. 10/594,892
	Applicant(s): Takeshi SAKAMOTO, et al.	
	Filing Date: June 19, 2007	Group Art Unit: 2812

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Hayashi, K. "Inner Glass Marking by Harmonics of Solid-State Laser", Proceedings of 45 th Laser Materials Processing Conference, December 1998, pgs. 23-28.
	Miura, K. et al. "Formation of Photo-Induced Structures in Glasses with Femtosecond Laser", Proceedings of 42 nd Laser Materials Processing Conference, November 1997, pgs. 105-111.
	Sano, T. et al. "Evaluation of Processing Characteristics of Silicon with Picosecond Pulse Laser", Preprints of the National Meeting of Japan Welding Society, No. 66, April 2000, pgs. 72-73 (with corresponding English-language translation).

Examiner /Calvin Choi/ Date Considered 07/09/2009

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.C./